



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG844656050
Report verification at igi.org

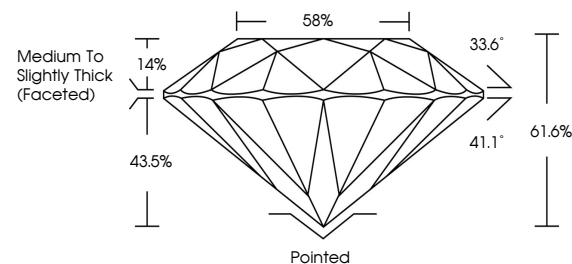
October 5, 2026	
IGI Report Number	LG844656050
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	10.20 - 10.24 X 6.29 MM
GRADING RESULTS	
Carat Weight	4.05 CARATS
Color Grade	F
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG844656050

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

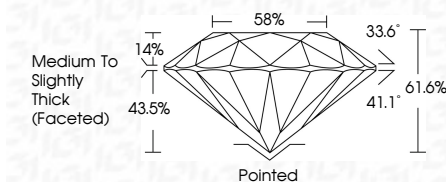
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

October 5, 2026	Color Grade	4.05 CARATS	F
GI Report No LG34465500	Carat Weight	10.20 - 10.24 X 6.20 MM	
ROUND BRILLIANT	Clarity Grade	VVS 2	
	Cut Grade	IDEAL	
	Depth	61.6%	
	Girdle	85%	
	Medium to slightly Thick (Faceted)		
Cluef	Polished		
Polish	EXCELLENT		
Symmetry	EXCELLENT		
Fluorescence	NONE		
Inscriptions(s)	lg31 LG34465500		

Comments:

This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IId